Electronic Acknowledgement Receipt				
EFS ID:	1751169			
Application Number:	10519475			
International Application Number:				
Confirmation Number:	2692			
Title of Invention:	Plasma processing system and its substrate processing process, plasma enhanced chemical vapor deposition system and its film deposition process			
First Named Inventor/Applicant Name:	Keisuke Kawamura			
Customer Number:	22850			
Filer:	Marvin Jay Spivak/Kendra Harvey			
Filer Authorized By:	Marvin Jay Spivak			
Attorney Docket Number:	263788US2PCT			
Receipt Date:	07-MAY-2007			
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Time Stamp:	16:41:14			
Application Type:	U.S. National Stage under 35 USC 371			

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Submitted with Payment	no	
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1		263788USELECTION.pdf	202314	yes	3

L	Multipart Description/PDF files in .zip description			
	Document Description	Start	End	
	Miscellaneous Incoming Letter	1	1	
	Response to Election / Restriction Filed	2	3	
Warnings:				

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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt. in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.